

MEMC 01-2801 (3005.3)  
PATENT

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Application of: Zheng Lu, et al. Art Unit: 1722  
Serial No.: 10/699,038  
Filed: October 31, 2003  
Confirmation No.: 1197  
For: PROCESS FOR PREPARING SINGLE CRYSTAL SILICON USING CRUCIBLE  
ROTATION TO CONTROL TEMPERATURE GRADIENT  
Examiner: Robert M. Kunemund

November 14, 2005

RESPONSE TO OFFICE ACTION

TO THE COMMISSIONER FOR PATENTS,

SIR:

In response to the Office action mailed June 14, 2005, please enter the following amendments and consider the following remarks.

Remarks begin on page 2 of this paper.

Conclusion begins on page 11 of this paper.